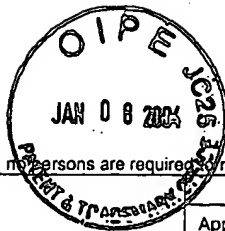


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Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete If Known	
				Application Number	09/620,943
				Filing Date	07/21/2000
				First Named Inventor	Robert Keller
				Group Art Unit	2882
				Examiner Name	Kao, Chih cheng G
Sheet	1	of	1	Attorney Docket No.	TI-30714

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
AB	AA	5,909,296		Tsacoyeanes	06/01/1999	
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					

FOREIGN PATENT DOCUMENTS								
Exam. Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ² (if known)				
AB	BA	EP	0 962 796 A2		Congdon	12/08/1999		
	BB							
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AB	CA	Tuantranont A et al., "Smart Phase-Only Micromirror Array Fabricated by Standard CMOS Process", Proceedings of the IEEE 13 th Annual International Conference on Micro Electro Mechanical Systems, MEMS 2000. Miyazaki, Japan, Jan. 23-27, 2000, IEEE, U.S. 23 January 2000 (2000-01-23), pages 455-460, XP001045359 ISBN: 0-7803-5274-2.	
	CB		
	CC		
	CD		
	CE		
	CF		
	CG		
	CH		

Examiner Signature	/Agustin Bello/ (01/08/2007)	Date Considered	
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